

**Notice of References Cited**Application/Control No.  
10/081,111Applicant(s)/Patent Under  
Reexamination  
WONG ET AL.Examiner  
ori nadavArt Unit  
2811

Page 1 of 1

**U.S. PATENT DOCUMENTS**

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name     | Classification |
|---|---|--|-----------------|----------|----------------|
|   | A | US-5158899                                       | 10-1992         | Yamagata | 437/27         |
|   | B | US-3525911                                       | 08-1970         | Ryerson  | 257/552        |
|   | C | US-  |                 |          |                |
|   | D | US-  |                 |          |                |
|   | E | US-  |                 |          |                |
|   | F | US-  |                 |          |                |
|   | G | US-  |                 |          |                |
|   | H | US-  |                 |          |                |
|   | I | US-  |                 |          |                |
|   | J | US-  |                 |          |                |
|   | K | US-  |                 |          |                |
|   | L | US-  |                 |          |                |
|   | M | US-  |                 |          |                |

**FOREIGN PATENT DOCUMENTS**

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
|   | N |  |                 |         |      |                |
|   | O |  |                 |         |      |                |
|   | P |  |                 |         |      |                |
|   | Q |  |                 |         |      |                |
|   | R |  |                 |         |      |                |
|   | S |  |                 |         |      |                |
|   | T |  |                 |         |      |                |

**NON-PATENT DOCUMENTS**

| * |   | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
|   | U | Complete guide to semiconductor devices, Kwok Ng, 1995, page 109.                         |
|   | V |   |
|   | W |   |
|   | X |   |

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.